

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** Jeffrey R. Amadon, et al.

**Examiner:** Unassigned

**Serial No:** To be assigned

**Art Unit:** Unassigned

**Filed:** Herewith

**Docket:** FIS920030072US2 (16405A)

**For:** METHOD OF FABRICATION  
OF THIN FILM RESISTOR  
WITH 0 TCR

**Dated:** December 4, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

In connection with filing the above-identified application under 37 C.F.R. §1.53(b), applicants submit the following amendments and remarks for consideration by the Examiner and entry of record in the above-identified patent application

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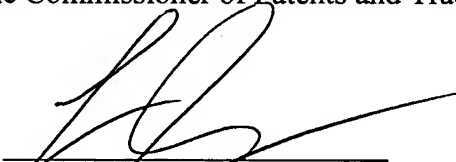
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Dated: December 4, 2003

  
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Leslie S. Szives, Ph.D.